

METHOD AND APPARATUS FOR A MULTIPOLE ION TRAP
ORTHOGONAL TIME-OF-FLIGHT MASS SPECTROMETER

1 TECHNICAL FIELD OF THE INVENTION

2 The present invention relates generally to means and method
3 whereby ions can be transferred efficiently from an ion source in
4 such a way that can be readily analyzed in a time-of-flight (TOF)
5 mass spectrometer. More specifically, an apparatus is described
6 which uses an ion trap and a multipole ion guide to obtain higher
7 resolution from an orthogonal TOF mass spectrometer.

8

9 BACKGROUND OF THE PRESENT INVENTION

10 The apparatus and methods for ionization described herein are
11 enhancements of the techniques that are referred to in the
12 literature relating to mass spectrometry. Mass spectrometry is an
13 important tool in the analysis of a wide range of chemical
14 compounds. Specifically, mass spectrometers can be used to
15 determine the molecular weight of sample compounds. The analysis
16 of samples by mass spectrometry consists of three main steps -
17 formation of gas phase ions from sample material, mass analysis of
18 the ions to separate the ions from one another according to ion
19 mass, and detection of the ions. A variety of means exist in the
20 field of mass spectrometry to perform each of these three

1 functions. The particular combination of means used in a given
2 spectrometer determine the characteristics of that spectrometer.

3 To mass analyze ions, for example, one might use a magnetic
4 (B) or electrostatic (E) analyzer. Ions passing through a magnetic
5 or electrostatic field will follow a curved path. In a magnetic
6 field the curvature of the path will be indicative of the momentum-
7 to-charge ratio of the ion. In an electrostatic field, the
8 curvature of the path will be indicative of the energy-to-charge
9 ratio of the ion. If magnetic and electrostatic analyzers are used
10 consecutively, then both the momentum-to-charge and energy-to-
11 charge ratios of the ions will be known and the mass of the ion
12 will thereby be determined. Other mass analyzers are the
13 quadrupole (Q), the ion cyclotron resonance (ICR), the time-of-
14 flight (TOF), and the quadrupole ion trap analyzers. The analyzer
15 which accepts ions from the ion guide described here may be any of
16 a variety of these.

17 Before mass analysis can begin, however, gas phase ions must
18 be formed from sample material. If the sample material is
19 sufficiently volatile, ions may be formed by electron ionization
20 (EI) or chemical ionization (CI) of the gas phase sample molecules.
21 For solid samples (e.g. semiconductors, or crystallized
22 materials), ions can be formed by desorption and ionization of

1 sample molecules by bombardment with high energy particles.
2 Secondary ion mass spectrometry (SIMS), for example, uses keV ions
3 to desorb and ionize sample material. In the SIMS process a large
4 amount of energy is deposited in the analyte molecules. As a
5 result, fragile molecules will be fragmented. This fragmentation
6 is undesirable in that information regarding the original
7 composition of the sample -- e.g., the molecular weight of sample
8 molecules -- will be lost.

9 For more labile, fragile molecules, other ionization methods
10 now exist. The plasma desorption (PD) technique was introduced by
11 Macfarlane et al. in 1974 (Macfarlane, R. D.; Skowronski, R. P.;
12 Torgerson, D. F., *Biochem. Biophys. Res Commun.* **60** (1974) 616).
13 Macfarlane et al. discovered that the impact of high energy (MeV)
14 ions on a surface, like SIMS would cause desorption and ionization
15 of small analyte molecules, however, unlike SIMS, the PD process
16 results also in the desorption of larger, more labile species --
17 e.g., insulin and other protein molecules.

18 Lasers have been used in a similar manner to induce desorption
19 of biological or other labile molecules. See, for example,
20 VanBreeman, R.B.: Snow, M.: Cotter, R.J., *Int. J. Mass Spectrom.*
21 *Ion Phys.* **49** (1983) 35; Tabet, J.C.; Cotter, R.J., *Anal. Chem.* **56**
22 (1984) 1662; or Olthoff, J.K.; Lys, I.: Demirev, P.: Cotter, R.

1 J., *Anal. Instrument.* **16** (1987) 93. Cotter et al. modified a CVC
2 2000 time-of-flight mass spectrometer for infrared laser desorption
3 of involatile biomolecules, using a Tachisto (Needham, Mass.)
4 model 215G pulsed carbon dioxide laser. The plasma or laser
5 desorption and ionization of labile molecules relies on the
6 deposition of little or no energy in the analyte molecules of
7 interest. The use of lasers to desorb and ionize labile molecules
8 intact was enhanced by the introduction of matrix assisted laser
9 desorption ionization (MALDI) (Tanaka, K.; Waki, H.; Ido, Y.;
10 Akita, S.; Yoshida, Y.; Yoshica, T., *Rapid Commun. Mass Spectrom.*
11 **2** (1988) 151 and Karas, M.; Hillenkamp, F., *Anal. Chem.* **60** (1988)
12 2299). In the MALDI process, an analyte is dissolved in a solid,
13 organic matrix. Laser light of a wavelength that is absorbed by
14 the solid matrix but not by the analyte is used to excite the
15 sample. Thus, the matrix is excited directly by the laser, and the
16 excited matrix sublimes into the gas phase carrying with it the
17 analyte molecules. The analyte molecules are then ionized by
18 proton, electron, or cation transfer from the matrix molecules to
19 the analyte molecules. This process, MALDI, is typically used in
20 conjunction with time-of-flight mass spectrometry (TOFMS) and can
21 be used to measure the molecular weights of proteins in excess of
22 100,000 daltons.

Atmospheric pressure ionization (API) includes a number of methods. Typically, analyte ions are produced from liquid solution at atmospheric pressure. One of the more widely used methods, known as electrospray ionization (ESI), was first suggested by Dole et al. (M. Dole, L.L. Mack, R.L. Hines, R.C. Mobley, L.D. Ferguson, M.B. Alice, *J. Chem. Phys.* **49**, 2240, 1968). In the electrospray technique, analyte is dissolved in a liquid solution and sprayed from a needle. The spray is induced by the application of a potential difference between the needle and a counter electrode. The spray results in the formation of fine, charged droplets of solution containing analyte molecules. In the gas phase, the solvent evaporates leaving behind charged, gas phase, analyte ions. Very large ions can be formed in this way. Ions as large as 1 MDa have been detected by ESI in conjunction with mass spectrometry (ESMS).

Many other ion production methods might be used at atmospheric or elevated pressure. For example, MALDI has recently been adapted by Victor Laiko and Alma Burlingame to work at atmospheric pressure (Atmospheric Pressure Matrix Assisted Laser Desorption Ionization, poster #1121, 4th International Symposium on Mass Spectrometry in the Health and Life Sciences, San Francisco, Aug. 25 - 29, 1998) and by Standing et al. at elevated pressures (Time of Flight Mass

1 Spectrometry of Biomolecules with Orthogonal Injection +
2 Collisional Cooling, poster #1272, 4th International Symposium on
3 Mass Spectrometry in the Health and Life Sciences, San Francisco,
4 Aug. 25 - 29, 1998; and Orthogonal Injection TOFMS Anal. *Chem.*
5 71(13), 452A (1999)). The benefit of adapting ion sources in this
6 manner is that the ion optics and mass spectral results are largely
7 independent of the ion production method used.

8 An elevated pressure ion source always has an ion production
9 region (wherein ions are produced) and an ion transfer region
10 (wherein ions are transferred through differential pumping stages
11 and into the mass analyzer). The ion production region is at an
12 elevated pressure -- most often atmospheric pressure -- with
13 respect to the analyzer. The ion production region will often
14 include an ionization "chamber" (e.g. FIG. 1, ionization chamber
15 4). In an ESI source, for example, liquid samples are "sprayed"
16 into the "chamber" to form ions.

17 Once the ions are produced, they must be transported to the
18 vacuum for mass analysis. Generally, mass spectrometers (MS)
19 operate in a vacuum between 10^{-4} and 10^{-10} torr depending on the
20 type of mass analyzer used. In order for the gas phase ions to
21 enter the mass analyzer, they must be separated from the background
22 gas carrying the ions and transported through the single or

1 multiple vacuum stages.

2 The use of multipole ion guides has been shown to be an
3 effective means of transporting ions through vacuum regions.
4 Publications by Olivers et. al. (Anal. Chem, Vol. 59, p. 1230-1232,
5 1987), Smith et. al. (Anal. Chem. Vol. 60, p. 436-441, 1988) and
6 U.S. Pat. No. 4,963,736 (1990) have reported the use of an AC only
7 quadrupole ion guide to transport ions from an API source to a mass
8 analyzer. A quadrupole ion guide operated in RF only mode,
9 configured to transport ions is described by Douglas et. al in U.S.
10 Patent 4,963,736. Multipole ion guides configured as collision
11 cells are operated in RF only mode with a variable DC offset
12 potential applied to all rods. Thomson et. al. in U.S. Patent
13 Number 5,847,386 describes a multipole ion guide assembly
14 configured to create a DC electric field along the ion guide axis
15 to move ions axially through a collision cell or to promote
16 Collision Induced Dissociation (CID) fragmentation.

17 Other schemes are available, which utilize both RF and DC
18 potentials in order to facilitate the transmission of ions of a
19 certain range of m/z values. For example, Morris et al., in H.R.
20 Morris et al., High Sensitivity Collisionally-Activated
21 Decomposition Tandem Mass Spectrometry on a Novel Quadrupole/
22 Orthogonal- acceleration Timon-of-Flight Mass Spectrometer, Rapid

1 Commun. Mass Spectrom. 10, 889 (1996), uses a series of multipoles
2 in their design, one of which is a quadrupole. The quadrupole can
3 be run in a "wide bandpass" mode or a "narrow bandpass" mode. In
4 the wide bandpass mode, an RF-only potential is applied to the
5 quadrupole and ions of a relatively broad range of m/z values are
6 transmitted. In narrow bandpass mode both RF and DC potentials are
7 applied to the quadrupole such that ions of only a narrow range of
8 m/z values are selected for transmission through the quadrupole.
9 In subsequent multipoles the selected ions may be activated towards
10 dissociation. In this way the instrument of Morris et al. is able
11 to perform MS/MS with the first mass analysis and subsequent
12 fragmentation occurring in what would otherwise be simply a set of
13 multipole ion guides.

14 Time-of-flight mass spectrometry (or TOFMS) plays an important
15 role in the analysis of chemical compounds. Specifically, TOF mass
16 spectrometers are useful in determining the molecular weight of
17 sample compounds. In orthogonal TOF mass spectrometers ions pass
18 from the source into the analyzer in a direction which is
19 orthogonal to the axis of the analyzer. The concept of orthogonal
20 acceleration using TOFMS was disclosed by O'Hallran et al. in 1964
21 (G.J. O'Halloran et al., *Determination of Chemical Species*
22 *Prevalent in a Plasma Jet*. Technical Documentary Report No. ASD-

1 TDR-62-664, prepared under contract AF 33(616)-8374 by the Bendix
2 Corp. Research Laboratories (1964)). O'Hallran et al. also
3 introduced the application of TOF mass analysis to ionization
4 sources at elevated pressure. One advantage to using orthogonal
5 acceleration and elevated pressure ionization sources is that ions
6 form a continuous beam and can be mass analyzed more efficiently.
7 Also, with the "orthogonal acceleration" method, the mass analysis
8 occurs along an axis which is orthogonal to the ion's initial
9 direction of motion. As a result, the initial energy of the ions
10 does not significantly degrade the mass resolution of the
11 instrument.

12 Chien and Lubman demonstrated the advantage of using a
13 quadrupole ion trap - TOF mass analyzer in the analysis of
14 electrospray produced ions (Chien, B.M.; Lubman, D.M., *Anal. Chem.*
15 66, 1630 (1994)). The ions from the electrospray source are
16 transferred with a high efficiency to the TOF analyzer and ions may
17 be preselected and collision induced dissociation on these ions may
18 be performed. One disadvantage with this method is low mass
19 resolving power. Also, there are restrictions in the time required
20 for cooling the ions and cycling the pressure in the ion trap.

21 Chernushevich et al discloses the use of ion introduction into
22 an RF-quadrupole ion guide at a high gas pressure (I.V.

1 Chernushevich, Proceedings of the 44th ASMS Conference of Mass
2 Spectrometry and Allied Topics, May 12-16, 1173 (1996)).
3 Similarly, Douglas discloses ion introduction into a quadrupole ion
4 trap rather than a TOF analyzer (D.J. Douglas, USPN 5,179,278).
5 Here, the ions are cooled by passage through the quadrupole ion
6 trap at elevated pressure and are transferred into a low pressure
7 region containing the TOF analyzer. This "collisional focusing"
8 method can be incorporated with the "orthogonal acceleration"
9 method to obtain a higher resolution mass spectra.

10 Morris et al. discloses the use of additional multipole
11 devices to preselect ions and induce collision dissociation in the
12 trap - TOF analyzer (H.R. Morris et al., *Rapid Comm. Mass Spectrom.*
13 10, 889 (1996)). Collision induced dissociation experiments were
14 disclosed in Lubman (B.M. Chien, S.M. Michael, D.M. Lubman, *Int J.*
15 *Mass Spectrom. Ion Process.*, 131, 149 (1994), B.M. Chien, D.M.
16 Lubman, *Anal. Chem.* 66, 1630 (1994)). There first multipole device
17 is used to cool ions then a second multipole is used for mass
18 selection, and a third multipole is used for collision induced
19 dissociation.

20 In orthogonal TOF mass spectrometer of the invention, ions are
21 trapped in a multipole ion guide having an apertured electrode at
22 its exit. By applying a repelling potential to the electrode, ions

1 near the exit of the multipole are reflected back into the guide
2 for trapping. During analysis, the potential of the electrode is
3 pulsed so that, during the duration of the pulse (20-100 us), ions
4 may exit the multipole.

5 Also, ions extracted from a multipole device and orthogonally
6 accelerated to the direction of the axis of the analyzer will have
7 a significant kinetic energy orthogonal to the axis of the
8 analyzer. This initial kinetic energy will cause the ions to drift
9 perpendicularly to the analyzer axis. This kinetic energy must be
10 accounted for in order to prevent ion loss and to ensure ion
11 detection. Also, during the extracting process, accelerated ions
12 will have its kinetic energy component increased in the direction
13 axial to the multipole. As the ions enter the accelerator of the
14 analyzer, the axial energy component will result in a decreased
15 mass resolution.

16 High efficiency in transmitting ions from the multipole to the
17 analyzer will require the spatial extent of the ion beam
18 perpendicular to the axis of the analyzer to be large compared to
19 that of prior art designs. As a result, some prior art devices
20 (i.e. the two stage reflectron taught by R. Frye in USPN 4,731,532)
21 cannot be used with the orthogonal multipole TOF device described
22 above.

1 An alternative "method and device for orthogonal ion injection
2 into a time-of-flight mass spectrometer" was proposed in Franzen
3 United States Pat. No. 5,763,878 (the "'878 patent"). According to
4 the '878 patent, ions are ejected from a multipole ion guide of
5 design similar to that of Chernushevich et al. into a time-of-
6 flight analyzer and in a direction orthogonal to the axis of the
7 multipole device. In trapping mode an RF potential is applied to
8 the poles of the multipole device whereas in ejection mode, DC
9 potentials are applied to the poles of the multipole device so as
10 to accelerate the ions in a direction orthogonal to the axis of the
11 multipole device and parallel to the axis of the TOF analyzer.

12 As shown in FIGS. 1 & 2, the '878 patent discloses multipole
13 devices having six poles (FIG. 1, elements 122-127) or four poles
14 (FIG. 2, elements 132-135) to trap and eject ions. Although the
15 spectrometer according to the '878 patent has certain advantages
16 over prior art, it is not ideal. One disadvantage of the
17 spectrometer according to the '878 patent is that the multipole
18 device of the '878 patent has a limited mass-to-charge ("m/z")
19 range. The m/z range of the device can be improved by increasing
20 the number of poles used -- for example, eight or more could be
21 used instead of the four or six poles used by the '878 patent.
22 Using more poles distributed in roughly a circular pattern around

1 the axis of the multipole would improve the m/z range of the device
2 while in trapping mode. However, when ejecting ions from the
3 device, the DC potential applied to each pole would have to be
4 controlled independently. Thus, in ejection mode, having a large
5 number of poles would be impractical.

6 Also, according to the '878 patent, the arrangement of
7 electrodes in the multipole is not ideal for the acceleration of
8 ions into a TOF analyzer. That is, it is difficult to produce a
9 uniform electrostatic field which accelerates ions in a direction
10 orthogonal to the hexapole. The electric field strength and
11 direction of acceleration of the ions during extraction from
12 multipole device of the '878 patent is dependent on the ion's
13 position within the multipole device. The electrostatic field
14 produced in an ideal TOF ion accelerator is completely homogeneous.
15 In other words, the electrostatic field strength and the direction
16 in which the ions are accelerated is not a function of position
17 within the accelerator.

18 FIG. 1 shows a section through a prior art Ion Trap in the
19 form of a hexapole with Pole Rods (122) to (127). The hexapole
20 arrangement is located between the Ion Repeller (121) and the Ion
21 Drawing Diaphragm (129), spaced about 12 millimeters from one
22 another. The hexapole arrangement houses the Ion Cloud (128)

1 formed as a thin thread which is made up of well-cooled ions. In
2 storage conditions, one phase of the storage RF voltage is applied
3 to Pole Rods (122), (124), and (126), and the other phase to Pole
4 Rods (123), (125), and (127). Ions of both polarities can be
5 stored. To outside positive ions, a more positive voltage is
6 applied to Pole Rods (122) and (125), a more negative voltage to
7 Rods (124) and (127) than to Rods (123) and (126). The Ion Drawing
8 Diaphragm (129) is designed as a slit diaphragm through which all
9 ions can be accelerated without loss. Slight beam divergences can
10 be focused through the cylindrical Einzel Lens (130) into a
11 parallel beam. Arrow (131) indicates the flight direction within
12 the time-of-flight spectrometer.

13 FIG. 2 shows a quadrupole arrangement made up of Pole Rods
14 (132) to (135). The pole rods are arranged asymmetrically here in
15 order to cause outpulsing solely through the external electrical
16 field between the Ion Repeller (121) and Ion Drawing Diaphragm
17 (129), without special voltages on the Pole Rods (132) to (135),
18 the RF voltage of which is simply switched off.

19 Also, the multipole device according to Franzen stores ions in
20 only one dimension. In particular, the '878 patent states that
21 "ions must be stored in the form of a thin thread in the axis" of
22 the multipole device. This substantially limits the number of ions

1 which can be stored in the device without encountering space charge
2 effects.

3

4 SUMMARY OF THE INVENTION

5 An object of the present invention is to provide an improved
6 method and apparatus for a multipole ion guide and trap (i.e.,
7 quadrupole, hexapole, octapole, etc.) for use in orthogonal TOFMS.
8 Specifically, the multipole ion trap-orthogonal time of flight mass
9 spectrometer of the present invention comprises an ion source, an
10 ion guide and trap, two reflectrons, and a detector. The ion guide
11 is connected downstream of the ion source and is disposed
12 orthogonal to the ion accelerator. The first reflectron is a two
13 stage gridless reflectron and it is disposed opposite the
14 accelerator. The second reflectron is a single stage gridded
15 reflectron and it is disposed opposite the first reflectron, in
16 between the ion flight region and the detector.

17 In the present invention, part of the accelerator is a single
18 trapping device which incorporates RF ion trapping and
19 electrostatic ion extraction. The device comprises two types of
20 electrodes--RF/DC electrodes, and DC electrodes. The RF/DC
21 electrodes are preferably positioned parallel to one another, while
22 the DC electrodes encompass the RF/DC electrodes. In a preferred

1 embodiment, there are two sets of electrodes, each containing both
2 the RF/DC electrodes and the DC electrodes. The sets of electrodes
3 are arranged parallel and adjacent to one another. Also, within
4 each set of electrodes, the RF/DC and DC electrodes are positioned
5 in the same plane.

6 During normal operation of the multipole ion trap, the DC
7 electrodes are held at a fixed DC potential. While trapping ions,
8 the DC potential (i.e., the time averaged potential) on the RF/DC
9 electrodes is held at a potential which is more attractive to the
10 ions than the potential on the DC electrodes. Also, a preferred
11 geometry of the device is such that the electrostatic field
12 gradient produced by the electrodes is strong near the DC
13 electrodes and virtually non-existent near the center. Also, the
14 RF potentials applied to adjacent RF/DC electrodes are 180 degrees
15 out of phase to repel ions toward the center of the multipole ion
16 trap. During trapping, the potential applied to the DC electrodes
17 must be of sufficient magnitude and the proper polarity to force
18 ions toward the center of the trap. Preferably, the dimensions of
19 the trap are chosen so that low energy ions (i.e., < 0.1 eV) can be
20 forced toward the center of the trap (i.e., to a region of 5mm
21 diameter) when trapping and the electrostatic field can be largely
22 homogeneous during extraction.

1 To extract the ions from the multipole ion trap, the
2 potentials on the RF/DC electrodes of each plane are held at two
3 different fixed potentials. The potential difference between the
4 planes accelerates the ions in a direction normal to the planes.
5 The geometry, magnitude and the frequency of the potentials are
6 crucial to the operation of the trap. The diameter of the planes
7 and the gap between them should provide a small distribution of
8 starting positions for the TOF analysis so that the potentials
9 applied to the electrodes for extraction of the ions result in a
10 short turn around time.

11 An object of the invention is to provide a multipole ion trap
12 which, during extraction produces an ion beam having a width small
13 enough (i.e., 5mm in diameter) to be used with any conventional
14 TOFMS devices. For example, the trap may be used with an RF/DC ion
15 guide, and the planes of the electrodes of the ion guide are
16 aligned parallel to the trap's electrodes and the center of the
17 trap is aligned with the center of the guide. This arrangement
18 allows the ions to move freely between the ion guide and the trap
19 when the potential on the connecting (or gate) electrode is
20 sufficiently low. This gate electrode can be closed by raising its
21 potential to match that of the other DC electrodes. By slowly
22 raising the gate potential, nearby ions will be forced into the

1 trap without maintaining a significant amount of kinetic energy.
2 The potential on the gate electrode is then maintained at the
3 potential of the DC electrodes during the trapping and extracting
4 process.

5 In accordance with the invention, the trap is preferably
6 disposed between and parallel to two planar electrodes and
7 comprises a fine conducting mesh. The accelerator portion
8 comprises guard ring electrodes and a gridded electrode which are
9 aligned parallel to one another and spaced at regular intervals.
10 While trapping, the electrodes adjacent to the trap are held at
11 neutral potentials. At this potential, there should be no
12 significant influence of these electrodes on the ions in the trap.

13 Conversely, during the extraction process, the planar
14 electrode between the guide and the trap is pulsed to a repulsive
15 potential, while the electrode between the trap and the accelerator
16 is pulsed to an attractive potential. This generates a homogenous
17 electric field with the same field gradient as that of the trap.
18 The ions then pass through the electrode nearest the guide and can
19 be accelerated by the electric field generated by the guard rings
20 and gridded electrodes. In the accelerator portion, the electrodes
21 are electrically connected by an RC network.

22 An object of the multipole ion trap according to the present

1 invention is to provide simplified and more efficient transfer ion
2 optics than conventional ion traps and ion guides, as well as prior
3 art orthogonal TOF mass spectrometers. Another object of the
4 invention is to provide a multipole ion trap having no significant
5 dependance on the m/z range of the instrument on the timing between
6 the gate and accelerator pulses as in prior art instruments. Yet
7 another object of the invention is to provide a multipole ion trap
8 in which there is no dependence of transmission efficiency through
9 the analyzer on the potential on a deflector often used in
10 conventional instruments. Yet a further object of the invention is
11 to provide a multipole ion trap wherein, in a given ion extraction,
12 more ions can be extracted and analyzed than by conventional means
13 and methods. In particular, in accordance with the present
14 invention, all (or substantially all) of the ions within the trap
15 will be extracted in a single pulse.

16 Other advantages of the present invention over prior art
17 include improved resolution in the TOF analyzer and the elimination
18 of correction for the initial orthogonal kinetic energy. These
19 advantages are the results of using truly thermal kinetic energy
20 ions. The ions in the trap will have only thermal kinetic energies
21 because the ions are not accelerated between the ion guide and
22 trap.

1 Other objects, features, and characteristics of the present
2 invention, as well as the methods of operation and functions of the
3 related elements of the structure, and the combination of parts and
4 economies of manufacture, will become more apparent upon
5 consideration of the following detailed description with reference
6 to the accompanying drawings, all of which form a part of this
7 specification.

8

9 BRIEF DESCRIPTION OF THE DRAWINGS

10 A further understanding of the present invention can be
11 obtained by reference to a preferred embodiment set forth in the
12 illustrations of the accompanying drawings. Although the
13 illustrated embodiment is merely exemplary of systems for carrying
14 out the present invention, both the organization and method of
15 operation of the invention, in general, together with further
16 objectives and advantages thereof, may be more easily understood by
17 reference to the drawings and the following description. The
18 drawings are not intended to limit the scope of this invention,
19 which is set forth with particularity in the claims as appended or
20 as subsequently amended, but merely to clarify and exemplify the
21 invention.

22 For a more complete understanding of the present invention,

1 reference is now made to the following drawings in which:

2 FIG. 1 depicts a prior art hexapole ion trap according to
3 Franzen United States Patent Number 5,763,878;

4 FIG. 2 depicts a prior art quadrupole ion trap according to
5 Franzen United States Patent 5,763,878;

6 FIG. 3 is an overall schematic drawing of a time-of-flight
7 mass analyzer incorporating the present invention;

8 FIG. 4 shows the preferred embodiment of the multipole ion
9 trap as used with an ion accelerator for use in TOF mass
10 spectrometry, according to the invention;

11 FIG. 5A shows a side view of the preferred embodiment of a
12 multipole ion trap according to the present invention;

13 FIG. 5B shows a cross-sectional view of the multipole ion trap
14 shown in FIG. 5A;

15 FIG. 6 depicts the multipole ion trap shown in FIGS. 4, 5A and
16 5B as used with an RF/DC ion guide;

17 FIG. 7 shows the multipole ion trap depicted in FIGS. 4, 5A
18 and 5B as used for an electron capture dissociation (ECD);

19 FIG. 8 demonstrates the introduction of low energy electrons
20 into the accelerator shown in FIG. 6 to produce negative ions from
21 neutral gas phase molecules, in accordance with the invention;

22 FIG. 9 is a graph of signal intensity vs. pulse duration

1 showing the intensity of the ion beam as a function of time during
2 an extraction pulse of 20 microseconds using the accelerator and
3 multipole ion trap depicted in FIGS. 5A, 5B and 6.

4

5 DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT

6 As required, a detailed illustrative embodiment of the
7 present invention is disclosed herein. However, techniques,
8 systems and operating structures in accordance with the present
9 invention may be embodied in a wide variety of forms and modes,
10 some of which may be quite different from those in the disclosed
11 embodiment. Consequently, the specific structural and
12 functional details disclosed herein are merely representative,
13 yet in that regard, they are deemed to afford the best embodiment
14 for purposes of disclosure and to provide a basis for the claims
15 herein which define the scope of the present invention. The
16 following presents a detailed description of a preferred
17 embodiment (as well as some alternative embodiments) of the
18 present invention.

19 Referring first to FIG. 3, depicted is a schematic drawing
20 of the preferred embodiment of a multipole ion trap orthogonal
21 time-of-flight (TOF) mass spectrometer according to the
22 invention. As shown, the (TOF) mass spectrometer 16 in

1 accordance with the present invention includes ion production
2 region 1, ion guide 2, accelerator/trap assembly 3, first flight
3 tube/region 4, first ion reflector 5, second flight tube/region
4 7, second ion reflector 6, detector 15. Generally, ions are
5 first generated in ion production region 1, which may be any
6 known ionization means or method (i.e., electrospray ionization
7 (ESI), plasma desorption ionization (PD), matrix assisted
8 laser/desorption ionization (MALDI), electron ionization (EI),
9 chemical ionization (CI), etc.). At some predetermined time
10 after formation, the ions are accelerated into ion guide 2 which
11 transports the ions to accelerator/trap 3. Ion guide 2 is
12 preferably an RF/DC ion guide. For example, the RF/DC ion guide
13 comprises a plurality of elongated electrode rods positioned
14 around a central axis such that when RF & DC potentials are
15 applied to the electrode rods, an electrostatic field is
16 generated, thereby allowing the transmission of the ions through
17 ion guide 2 - from its entrance end (at ion production region 1)
18 to ion accelerator/trap 3.

19 As the ions exit ion guide 2, they are introduced into
20 accelerator/trap 3, which, as shown in FIG. 6, preferably
21 comprises ion trap 10 (as further depicted in FIGs. 5A & 5B)
22 disposed between and parallel to planar electrodes 17 & 18, a

1 plurality of regularly spaced parallel guard ring electrodes 8
2 and gridded electrode 19 (which is aligned parallel to guard ring
3 electrodes 8). Preferably, planar electrodes 17 & 18 are mesh
4 gridded electrodes, but other forms of apertured electrodes may
5 be used. The ions first reach ion trap 10 where, in a preferred
6 embodiment, the ions are trapped for some predetermined time
7 prior to orthogonal acceleration into the mass analyzer.

8 Preferably, ion trap 10, as shown in FIGS. 5A and 5B, comprises
9 two substantially parallel planar series of electrodes (i.e.,
10 each series of electrodes comprises, preferably, six RF/DC
11 electrode rods 12 aligned in parallel and in a single plane, and
12 two curved DC cap electrodes 13, as depicted in FIGS. 5A & 5B).
13 Preferably, RF/DC electrode rods 12 are of lengths such that
14 there parallel and planar alignment results substantially in a
15 circular pattern. This allows curved DC cap electrodes 13 to
16 substantially surround the ends of RF/DC electrodes 12 -- one DC
17 cap electrode 13 at either end of RF/DC electrode rods 12. Of
18 course, in accordance with the invention, ion trap 10 may
19 comprise more or less than six RF/DC electrode rods 12.

20 Depending upon the potential(s) applied to the electrodes of
21 accelerator/trap 6 (see FIG. 4), the ions are either trapped
22 therein or accelerated into flight tube/region 8 toward first

1 reflector 10. As shown, accelerator/trap 6/7 is positioned such
2 that ions may be transferred from ion trap 6 to TOF accelerator 7
3 which comprises guard ring electrodes 16 and gridded electrodes
4 36 and 38.

5 Referring now to multipole ion guide 22, as depicted in FIG.
6 6, a preferred embodiment of multipole ion guide 6 comprises of
7 RF guide electrodes 40 and is connected to ion trap 20 by a gate
8 electrode 44. As shown, the ion guide 22 is positioned such that
9 ions coming from the entrance 42 may be transferred through the
10 guide 22 and into trap 20 via the gate electrode 44. Diagram 46
11 in FIG. 6 shows how the potential on the gate electrode can be
12 varied at the different stages of operation.

13 Turning now to ion trap 20, as depicted in FIGs. 5A and 5B,
14 a preferred embodiment of ion trap 20 is shown comprising two
15 sets of electrodes, RF/DC electrodes 24 and DC electrodes 26.
16 Each set consists of RF/DC electrodes 24 arranged parallel to one
17 another and DC electrodes 26 which encompass the RF/DC electrodes
18 24. The electrodes 24 & 26 of each set are arranged in parallel
19 and adjacent planes. The device depicted in FIGs. 5A and 5B is
20 only part of the larger accelerator/trap 6 instrument depicted in
21 FIG. 3. As shown, the ions 28 are trapped in an elongated region
22 at the center of the trap 20. Also, diagram 52 shows how the

1 voltage will vary at each stage of operation of trap 20. At one
2 stage of operation the ions 28 will exit the trap and enter the
3 TOF accelerator as shown in FIG. 3.

4 Next, FIG. 9 shows results of a prior art experiment
5 involving ions ejected from a multipole ion guide having a pulsed
6 exit aperture. The ions were trapped in a multipole ion guide by
7 applying a repelling potential on the apertured electrode at its
8 exit. A pulse of ions is produced for analysis by pulsing the
9 aperture electrode. Ions may exit the multipole (in this case a
10 hexapole) and enter the detector for the duration of the pulse.
11 FIG. 8 depicts the intensity of the ion beam as a function of
12 time during an extraction pulse of 20 us. Only a certain fraction
13 of the ions extracted from the multipole will be between the
14 repeller and grid simultaneously and only that fraction will be
15 useful in the TOF analysis. The extraction duration is selected
16 to optimize this fraction of useful ions.

17 During operation, ions 28 are generated by the ion
18 production region 2 and are introduced to the accelerator/trap 6
19 via multipole ion guide 4. The region near the ion entrance 42 is
20 filled with neutral gas held at moderate pressure to cool the
21 ions to thermal energies. The pressure of the gas near the trap
22 20 is relatively low compared to the pressure near the entrance

1 region. The potential on the gate electrode 44 is held at a
2 potential near ground and ions 28 can pass from the guide to the
3 trap. As shown in FIG. 6, the gate 44 potential can be closed by
4 slowly raising its potential until it is the same potential as
5 the other DC electrodes 26. The ions 28 will not be able to enter
6 the trap 20, and the trap/extract process may begin. If the
7 potential energy is raised slowly enough, then the ions 28 forced
8 into the trap 20 will not have significant kinetic energy.

9 After the ions 28 have passed the multipole guide 22 and
10 entered the trap 20, the trap 20 is turned on and the ions 28 are
11 forced into an elongated region near its center. As depicted in
12 FIGs. 5A and 5B, the electrodes 24 & 26 and their placement in
13 the trap 20 is out of proportion and is intended only to
14 illustrate the concept of trapping and extracting ions 28
15 according to the present invention. In a more practical example,
16 the RF/DC electrodes 24 might have a diameter of 50 um and the
17 gap between the planes might be 1 mm. The electrodes 24 need not
18 be cylindrical but could be, for example, rectangular in cross
19 section. The planes of RF/DC electrodes 24 might have a diameter
20 of 10 mm. The DC electrodes 26 might have an inner diameter of
21 10.1 mm and be biased to a potential of 20 V to trap positive
22 ions. During trapping mode operation, the RF potential applied to

1 the RF/DC electrodes 24 might take the form of a square wave of a
2 frequency of 5 MHZ, a peak-to-peak voltage of 200 V, and a time
3 averaged potential of 0V. Adjacent RF/DC electrodes 24 within a
4 given plane would experience potentials 180 degrees out of phase.
5 During extraction mode operation, the RF/DC electrodes 24 of one
6 plane would all be held at a DC potential of 100V whereas the
7 potential applied to the opposite plane would be -100 V. The
8 potential difference between the planes of electrodes 24 & 26
9 accelerates the ions 28 out of the trap 20 in a directions normal
10 to the planes.

11 As shown in FIG. 4, the extracted ions 28 are transferred
12 into the TOF ion accelerator 16, 18 & 38. During ion trapping,
13 the electrodes 34 & 36 are held at neutral potentials. During
14 extraction, the potential on electrode 34 is pulsed to a
15 repulsive potential V1. The potential on electrode 36 is pulsed
16 to an attractive potential V2. V1 and V2 are selected so as to
17 produce a homogeneous field between electrodes 34 & 36. The
18 pulsed voltage V2 and the DC potential -HV applied to either end
19 (36 & 38, respectively) of the RC network 18 is divided and
20 applied to the electrodes.

21 As depicted in FIG. 3, the ions 28 are accelerated by the
22 TOF accelerator 7 toward reflectron 10. It is possible to use a

1 two stage reflectron because of the relatively small diameter
2 (5mm) of the ion beam 8 and 14. In such case, the ions will
3 then be reflected towards the second reflectron 12 and eventually
4 end up in the detector 30. However, alternatively the MIT-OTOF
5 may take the form of a linear reflectron instrument (i.e.,
6 without the second reflectron, or with two coaxial reflectrons.

7 Next, FIG. 7 shows an alternate embodiment of multiple ion
8 trap 20 according to the present invention depicting the use of
9 ion trap 20 with electron capture dissociation ("ECD"). ECD is a
10 method of forming fragment ions from multiply and positively
11 charged ions. Specifically, the ions capture low energy
12 electrons 54. The formed fragments can be analyzed to reveal
13 structurally useful information about the original ion. A
14 detailed discussion of the ECD method is given by R.A. Zubarev,
15 J. Amer. Chem. Soc., 120, 3265 (1998) et al. As shown in FIG. 7,
16 electrons 54 are injected in a direction parallel and between the
17 two planes of trap electrodes 24 & 26 and perpendicular to the
18 axis of accelerator 7, the analyzer (not shown) and the ion guide
19 (not shown). The DC electrodes 26 are held at a positive DC
20 potential during the trapping stage, and the injected electrons
21 54 are accelerated and decelerated by the DC electrodes 26 as
22 they enter the trap 20. Magnets 56 and 57 are used to help

1 direct the electrons 54 into trap 20. Slits (not shown) may be
2 used between the electron filament 58 and trap 20 to remove
3 divergent portions of the electron beam. Alternatively, the
4 electron beam could be energy filtered before injection into trap
5 20. Also, higher energy electrons might be used to ionize
6 neutral molecules in trap 20. It is possible to produce and
7 inject the low energy electrons required by ECD into trap 20
8 because the kinetic energy of the ions in trap 20 is the same as
9 before they entered trap 20.

10 Turning next to FIG. 8, shown is yet another alternate
11 embodiment of multiple ion trap 20 according to the present
12 invention. FIG. 8 depicts low energy electrons 60 , from
13 filament 58, used to produce negative ions from neutral gas phase
14 molecules. As shown in FIG. 8, the electrons 60 are produced
15 using filament 58 and introduced from the back of the ion trap 20
16 since negative ions are to be produced and DC electrodes 26 would
17 have to be held at negative potentials if the ions were to be
18 introduced through the top or bottom of trap 20. Electrons 60
19 will have low kinetic energies and will be able to pass into
20 multiple ion trap 20 only when the potential on RF/DC electrodes
21 24 is near zero volts. The RF potential applied to RF/DC
22 electrodes 24 might be varied from the square wave depicted in

1 diagram 62 of FIG. 8 so that RF/DC electrodes 24 are near ground
2 potential for a longer period of time. Other waveforms may be
3 used to enhance the transmission of electrons 60 into trap 20, or
4 to reduce the electron energy once in trap 20. Once in trap 20,
5 electrons 60 may ionize molecules according to the "reversal
6 electron attachment" ("READ") method. To assist in the READ
7 process, a potential difference may be applied between the two
8 planes of RF/DC electrodes 24 as well as between adjacent RF/DC
9 electrodes 24 to "slow down" electrons 60 and then turn them
10 around while in trap 20. This

11 While the present invention has been described with
12 reference to one or more preferred embodiments, such embodiments
13 are merely exemplary and are not intended to be limiting or
14 represent an exhaustive enumeration of all aspects of the
15 invention. The scope of the invention, therefore, shall be
16 defined solely by the following claims. Further, it will be
17 apparent to those of skill in the art that numerous changes may
18 be made in such details without departing from the spirit and the
19 principles of the invention. It should be appreciated that the
20 present invention is capable of being embodied in other forms
21 without departing from its essential characteristics.